



ATTY DKT. No.: AMAT/5619/DSM/LOW K/JW
U.S. SERIAL No.: 09/012,103
FILED: JUN 23, 2001
APPLICANT: APPLIED MATERIALS, INC.
TITLE: SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER SILICON OXIDE STOP ETCH LAYERS
INVENTOR: NGUYEN, ET AL.
EXPRESS MAIL No.: N/A

CONF. No.: 447

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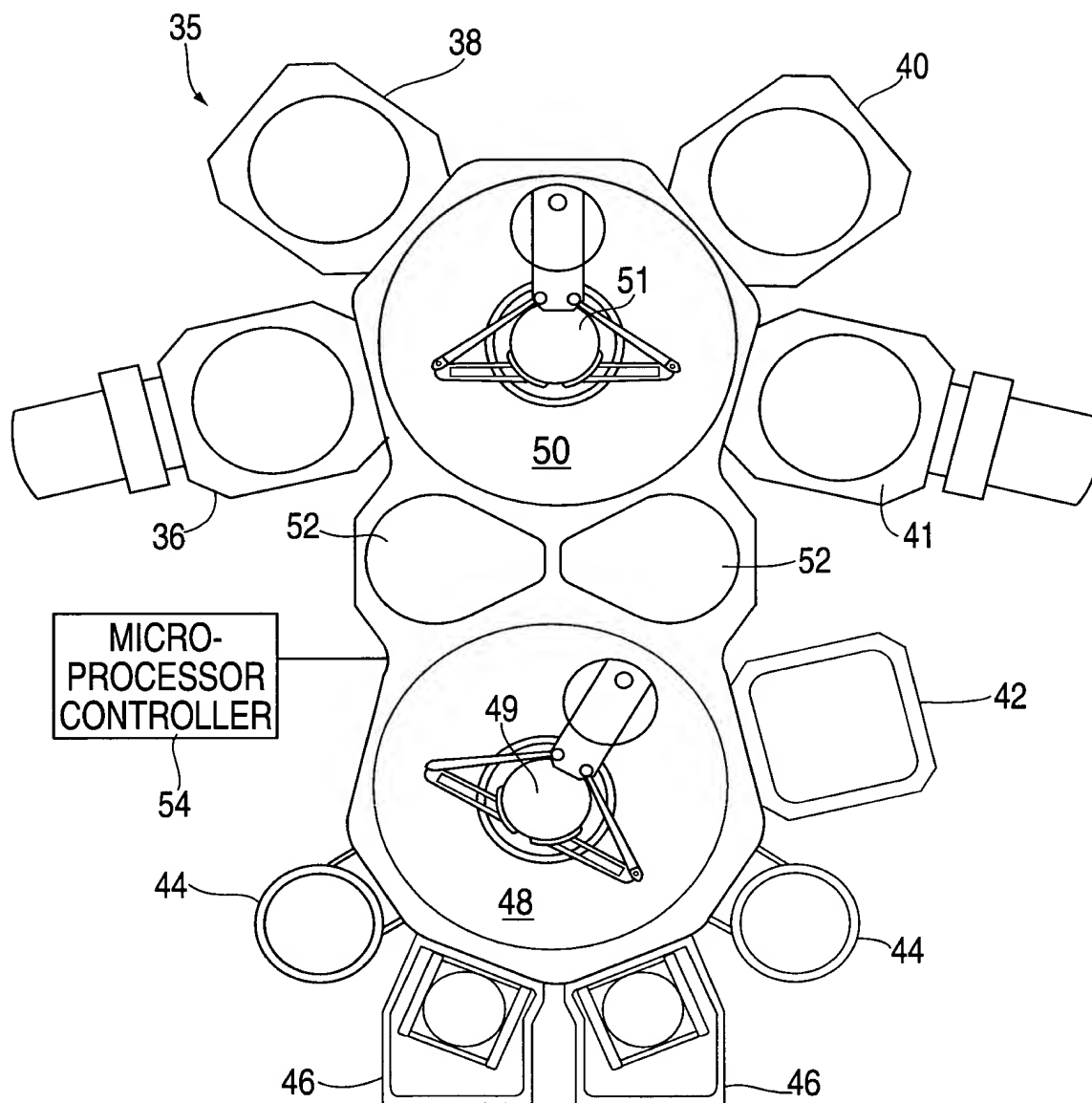


FIG. 1

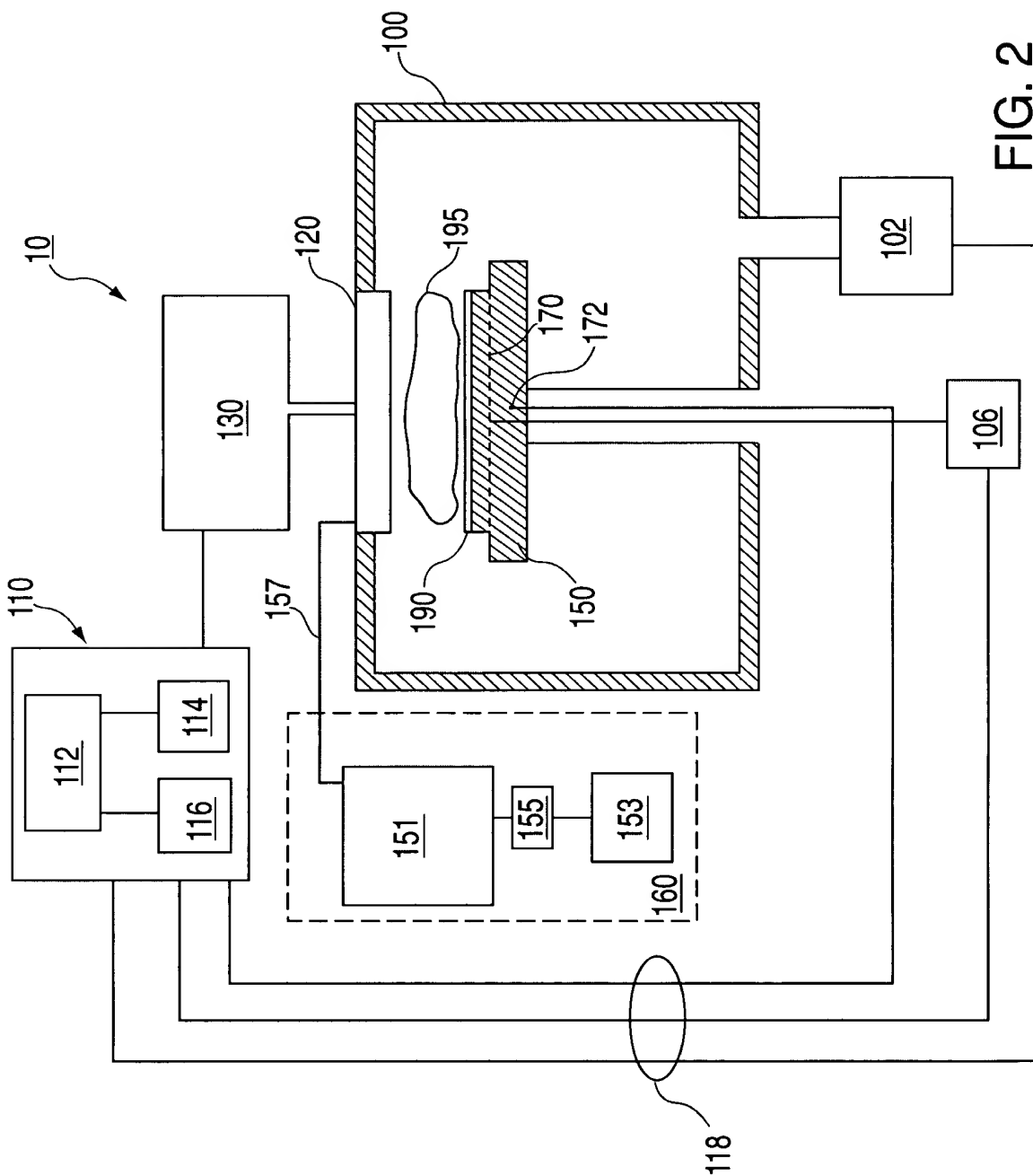


FIG. 2

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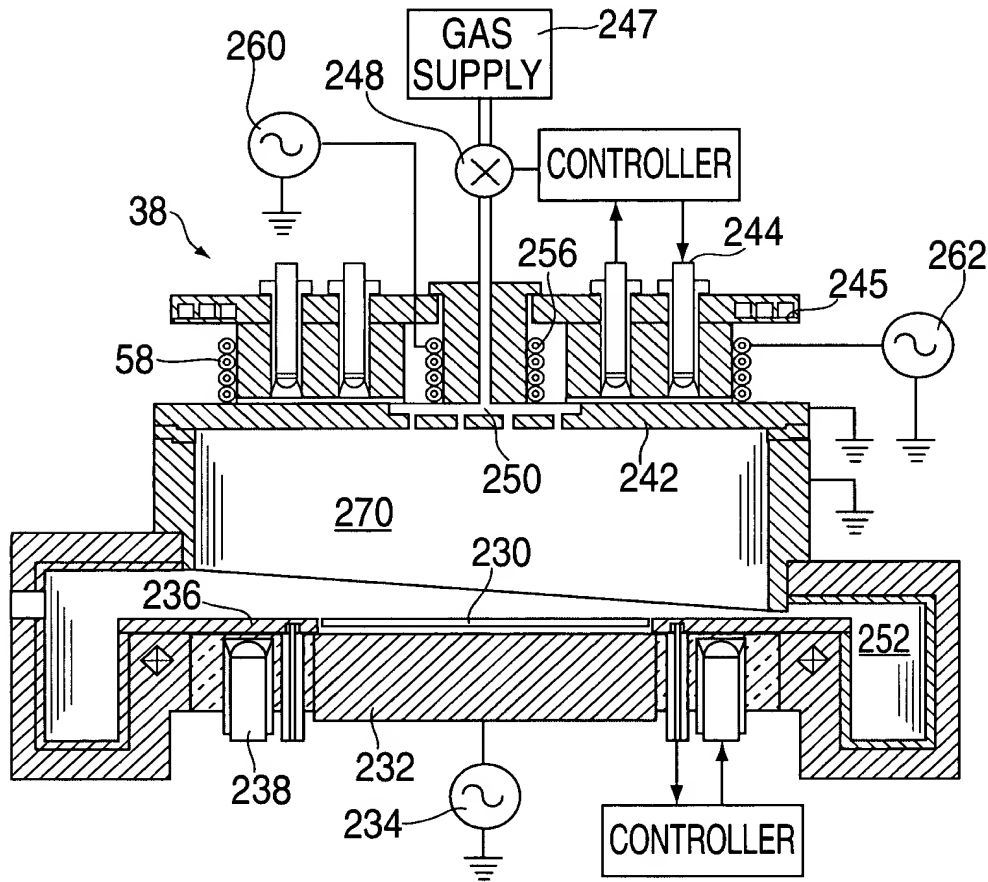


FIG. 3



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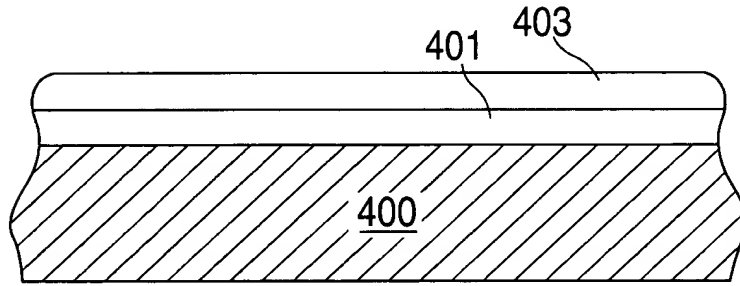


FIG. 4a

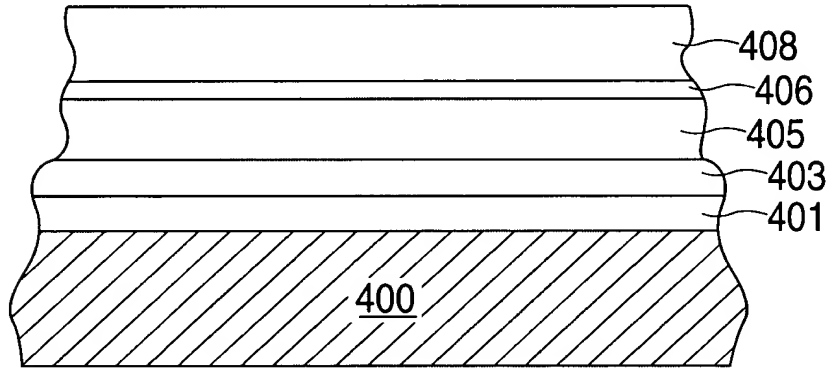


FIG. 4b

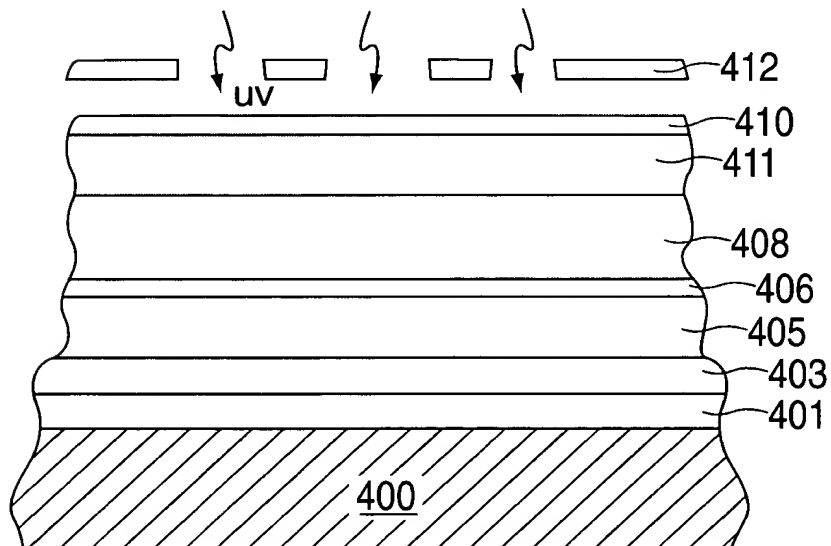


FIG. 4c



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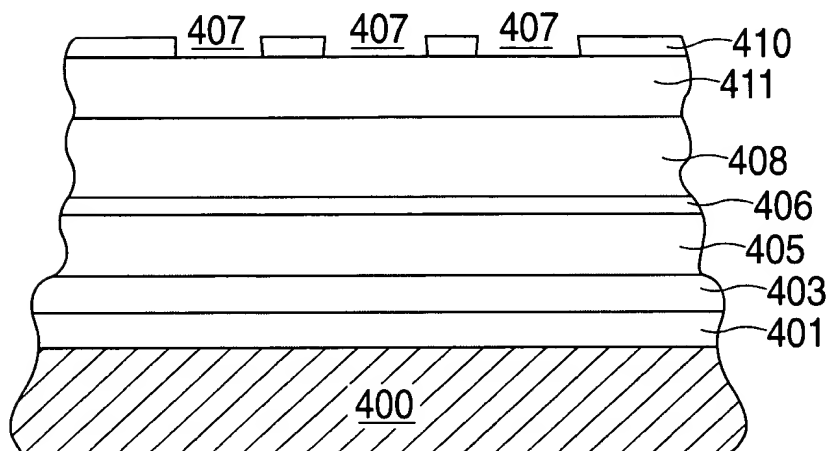


FIG. 4d

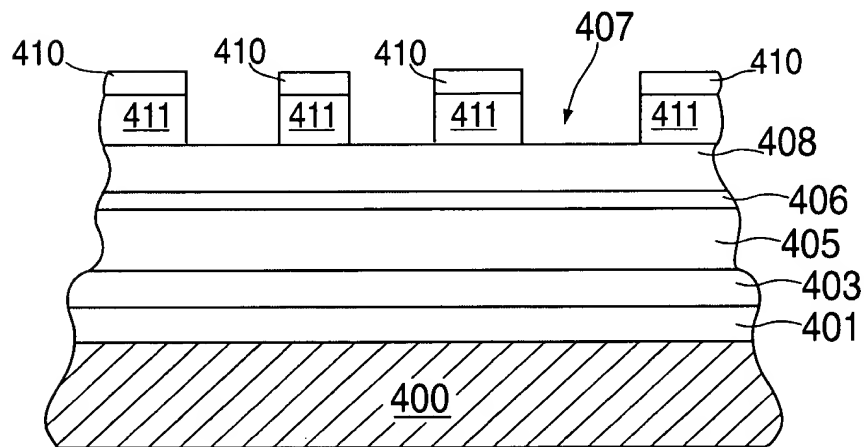


FIG. 4e



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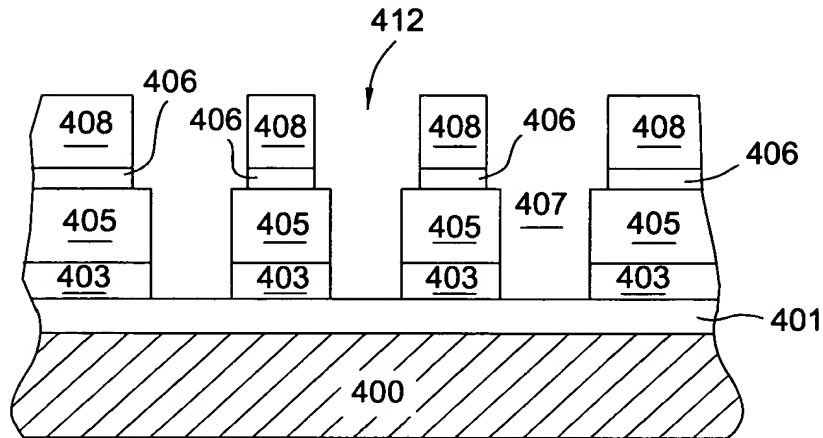


FIG. 4F

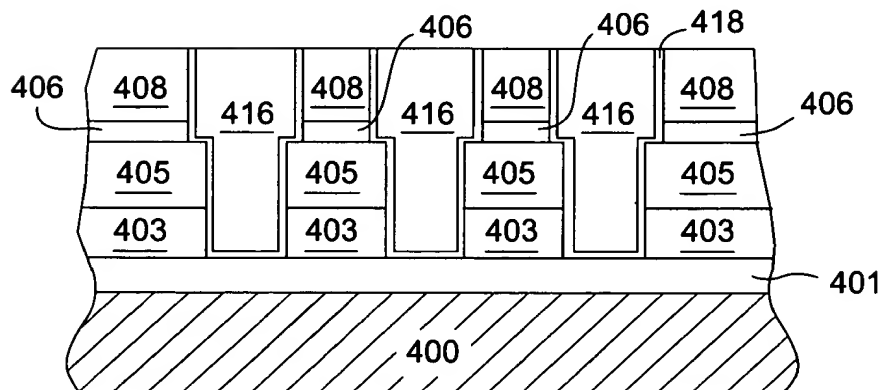


FIG. 4G